

AFJPW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of Response Under 37 CFR 1.116 - Expedited Procedure

: Customer Number: 20277

Junichi SHIOMI, et al.

: Confirmation Number: 1977

Application No.: 10/086,877

: Group Art Unit: 2623

Filed: March 04, 2002

: Examiner: Chong R. Kim

For: DETECTION OF AN END POINT OF POLISHING A SUBSTRATE

Mail Stop AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is an Amendment in the above-identified application.

☒
☐
☐

No additional fee is required.

Applicant is entitled to small entity status under 37 CFR 1.27

Also attached:

The fee has been calculated as shown below:

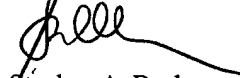
	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	6	20	0	\$50.00 =	\$0.00
Independent Claims	6	9	0	\$200.00 =	\$0.00
Multiple dependent claims newly presented					\$0.00
Fee for extension of time					\$0.00
					\$0.00
Total of Above Calculations					\$0.00

☐ Please charge my Deposit Account No. 500417 in the amount of \$0.00. An additional copy of this transmittal sheet is submitted herewith.

☒ The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 500417, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP



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 Date: September 23, 2005

Please recognize our Customer No. 20277 as our
 correspondence address.



Docket No.: 050063-0064

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Junichi SHIOMI, et al.

RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE

Application No.: 10/086,877

Customer No.: 20277

Filed: March 04, 2002

Confirmation No.: 1977

Group Art Unit: 2623

Examiner: Chong R. Kim

Title: DETECTION OF AN END POINT OF POLISHING A SUBSTRATE

AMENDMENT UNDER 37 CFR 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated July 26, 2005, please amend the above-identified application as follows: